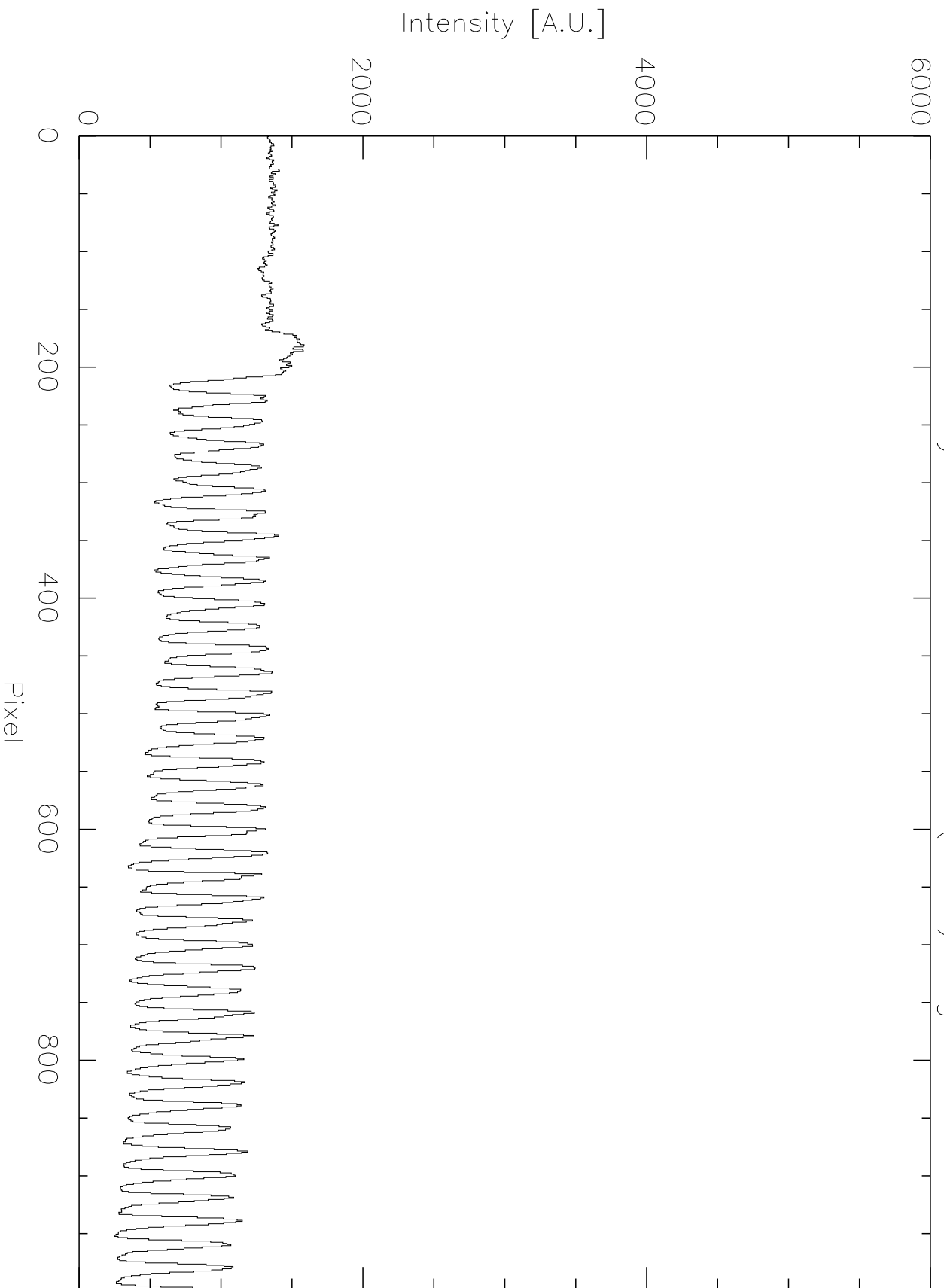
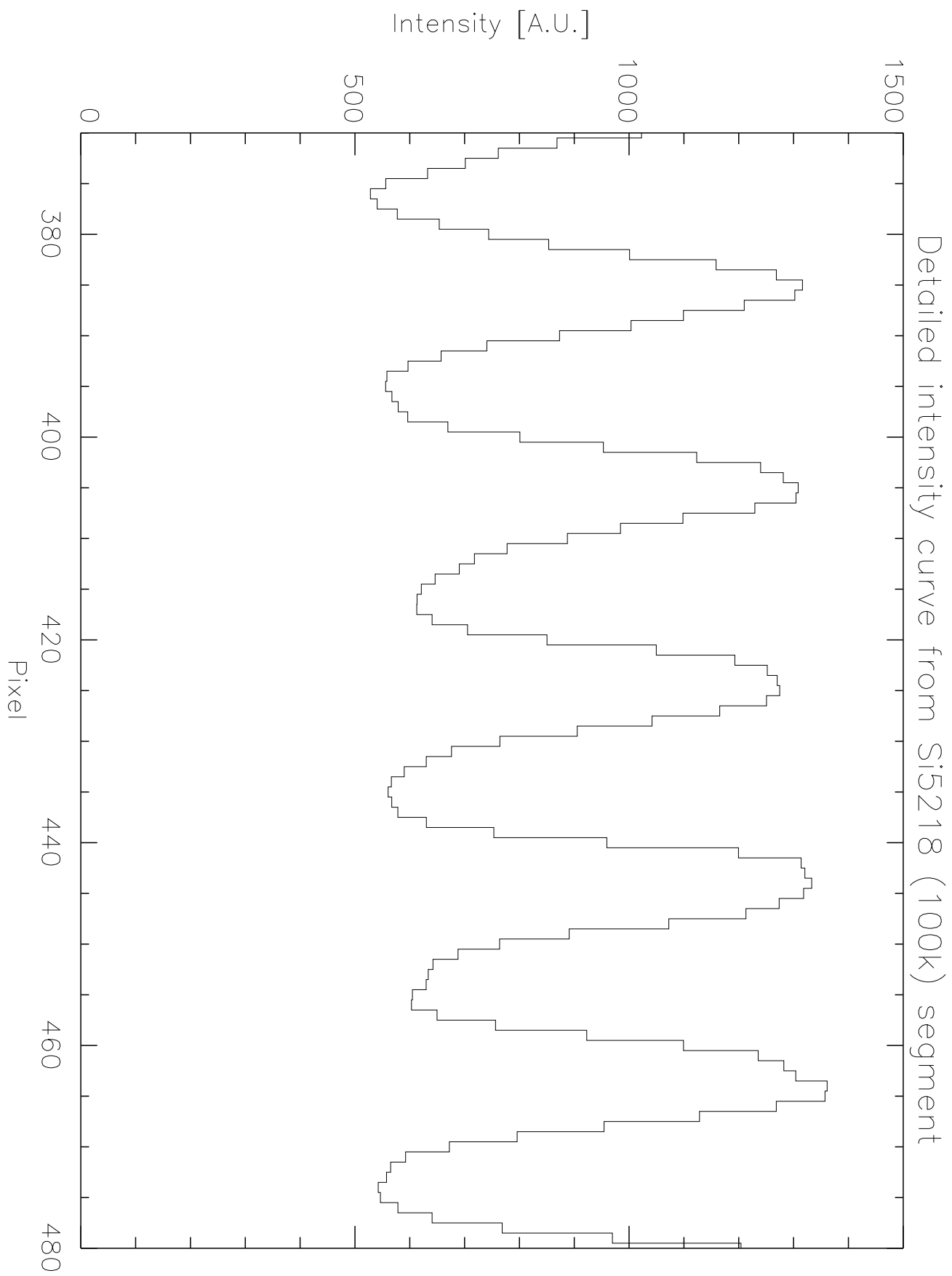
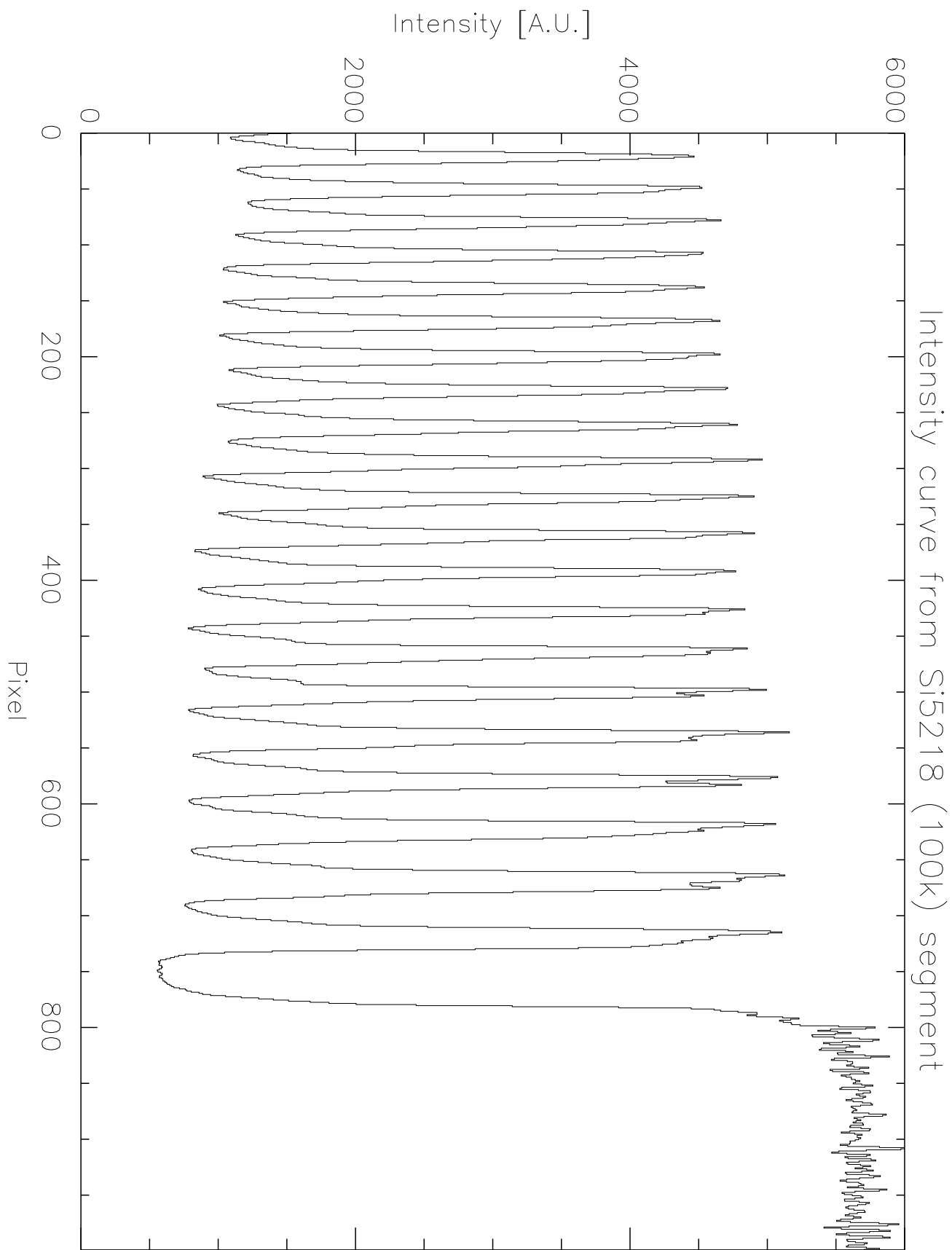
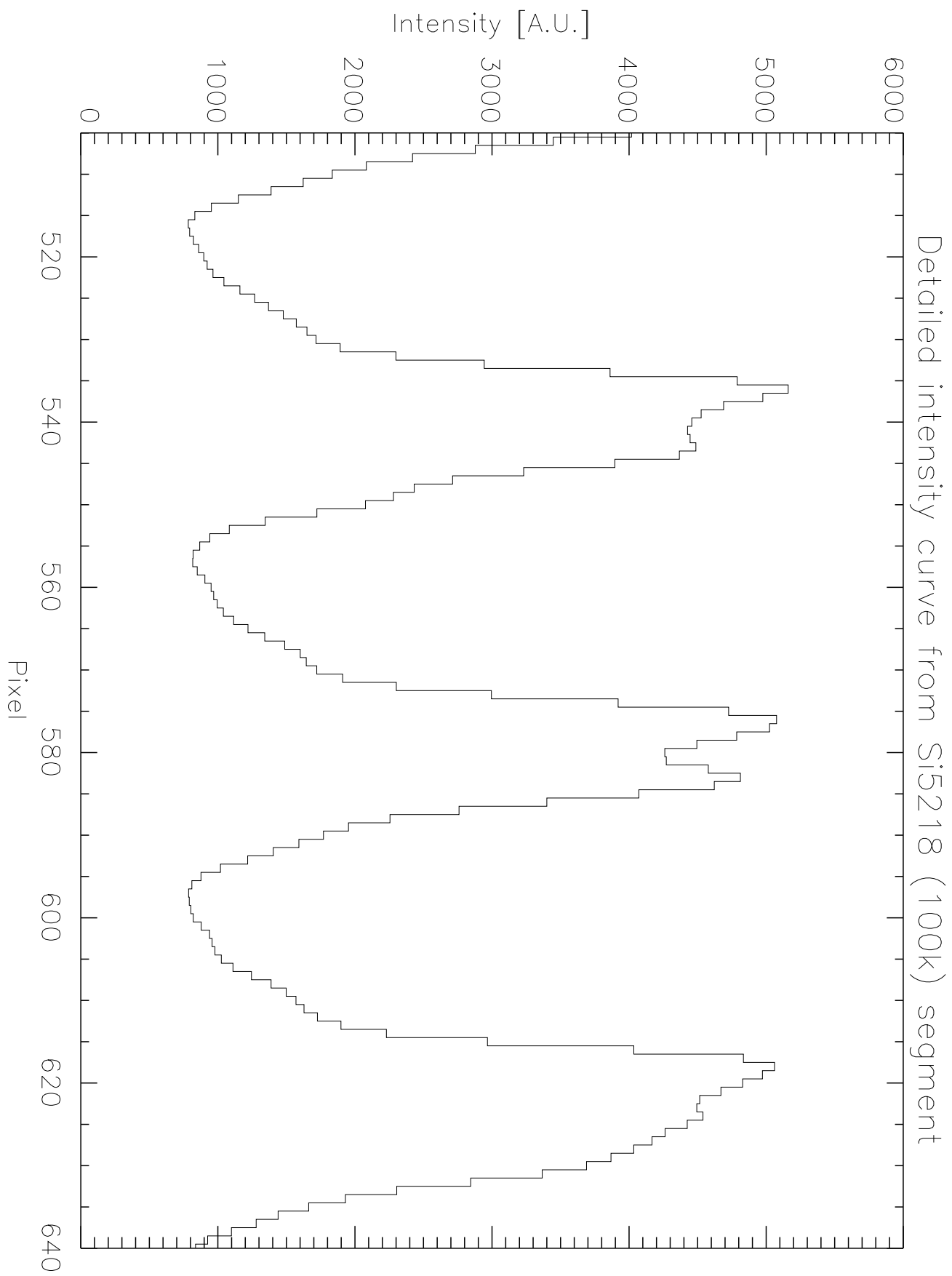


Intensity curve from Si5218 (100k) segment









TEM estimated relative d-spacing (Si5218)

